

Docket No. 0524-0439.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	
Nozawa et al.	I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on
Serial No.: 10/771,997)	
Filed: February 4, 2004)	Date of Deposit)
For: Manufacturing Method And Apparatus of) Phase Mask Shift Blank)	Shannon Wallace Name of applicant, assignee, or Registered Rep.
Examiner: Steven Versteeg)	Signature Date
Art Unit: 1753)	

AMENDMENT B

Commissioner of Patents P. O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In furtherance of Amendment A filed January 13, 2005, in response to the Office Action of September 13, 2004, a one month extension of time submitted therewith, please amend the above-identified application as follows:

01/31/2005 MBIZUNES 00000140 10771997

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